



Appl. No. 09/905,286

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,286
Filing Date July 13, 2001
Inventor..... Cem Basceri et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1762
Examiner Fuller, Eric B.
Attorney's Docket No. MI22-1724
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
Comprising Dielectric Layers

RESPONSE TO JUNE 20, 2003 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
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AMENDMENTS

Introductory Comments

In response to the Office Action dated June 20, 2003, applicant amends and remarks
as follows.

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